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PATENT
8032-1029

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Kenichi ISHII Conf. 4870

Application No. 10/623,545 Group 2687

Filed July 22, 2003 Examiner D. Lam

LOCATION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, a copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

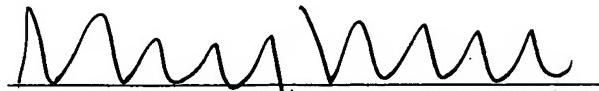
A concise explanation of the relevance of this item is that this reference was cited by the Chinese Patent Office in an Official Action. A copy of the Chinese Official Action in which it was cited is attached hereto. **An English translation is also attached hereto.**

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

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September 1, 2005



**E INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:
8032-1029

Application No.:
10/623,545

Applicant:
Kenichi ISHII

Filing Date:
July 22, 2003

Group Art Unit:
2687

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* Abstract provided for the Examiner's convenience